

Application/Control No.	Applicant(s)/Patent under Reexamination LIU ET AL.	
09/877,622		
Examiner	Art Unit	
Jennifer T. Nguyen	2629	

SEARCHED					
Class	Subclass	Date	Examiner		
345	173	519106	JN		
	174_				
_	179				
178	18.01				
	18.03-				
	18.08				
	19.01-				
	19.07				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
345	173 - 179	518106	24)		
178	18.01-18.0	5/8/06	JN		
	19.01-19.07				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
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